

Notice of References Cited

Application/Control No.

10/020,034

Applicant(s)/Patent Under

Reexamination

MITROS ET AL.

Examiner

Long Pham

Art Unit

2823

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-US006143594A	11-2000	Tsao et al.	
	C	US-US006188109B1	02-2001	Takahashi	
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	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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